

**PATENT**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of	)	
KOROLIK et al.	)	Group Art Unit: 1746
	)	
	)	Examiner: Heckert, Jason Mark
Application No.: 10/817,398	)	
	)	Docket No.: LAM2P467
Filed: April 1, 2004	)	
	)	Date: Oct. 2, 2008
For: CONTROLS OF AMBIENT	)	
ENVIRONMENT DURING WAFER DRYING	)	
USING PROXIMITY HEAD	)	
	)	

---

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This paper is in response to the Office Action dated July 2, 2008. The term for response extends to Oct. 2, 2008. Please enter this amendment.

**Amendments to the claims** are reflected in the listing of claims which begin on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.